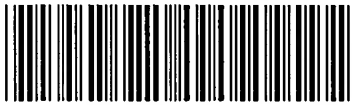


Search Notes

Application/Control No.

10/739,224

Examiner

Kelly L. Jerabek

Applicant(s)/Patent under
Reexamination

TAKESHITA, TETSUYA

Art Unit

2622

SEARCHED

| Class | Subclass | Date | Examiner |
|-------|----------|----------|----------|
| 348 | 223.1 | 2/9/2007 | KJ |
| | 225.1 | | |
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INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
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**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

| | DATE | EXMR |
|--------------|----------|------|
| IEEE | 2/9/2007 | KJ |
| EAST Keyword | 2/9/2007 | |
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